

**Search Notes**

Application/Control No.

10/689,983

Examiner

Ernest F. Karlsen

Applicant(s)/Patent under  
Reexamination

MATSUMOTO, CHIAKI

Art Unit

2829

**SEARCHED**

Class	Subclass	Date	Examiner
324	758 754 765 158.1	3/17/2017	E.F.K.

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
324	758 158.1	3/17/2017	E.F.K.

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
vacuum same tray same (align or alignment)	3/17/2017	E.F.K.
tray same semiconductor and test		